

## FORM PTO-1449

Atty. Docket No.

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J903 U.S. PTO 10/046077  
01/16/02LIST OF DOCUMENTS CITED BY APPLICANT

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Hirosi INAGAWA et al.

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## U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						

## FOREIGN PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
<i>DS</i>	AJ	8-23092	1/23/96	JAPAN			Abstract
<i>DS</i>	AK	2000-277531	10/6/00	JAPAN			Abstract
<i>DS</i>	AL	9-246550	9/19/97	JAPAN			Abstract
	AM						
	AN						
	AO						

## OTHER (including author, title, date, pertinent pages, etc.)

<i>DS</i>	AP	Semiconductor Handbook, 1981, pp. 429-430.
	AQ	
	AR	

Examiner	<i>DS</i>	Date Considered
		<i>10/18/03</i>

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.